

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Fukuda et al.) Group Art Unit Unknown
App. No. : Unknown)
Filed : Herewith)
For : A SEMICONDUCTOR-)
PROCESSING DEVICE)
PROVIDED WITH A REMOTE)
PLASMA SOURCE FOR SELF-)
CLEANING)
Examiner : Unknown)

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JC972 U.S. PTO
09/764523
01/18/01

INFORMATION DISCLOSURE STATEMENT

Assistant Commissioner for Patents
Washington, D.C. 20231

Dear Sir:

Enclosed is form PTO-1449 listing references that are also enclosed. This Information Disclosure Statement is being filed within three months of the filing date of this application, and no fee is required in accordance with 37 C.F.R. § 1.97(b)(1).

Respectfully submitted,

KNOBBE, MARTENS, OLSON & BEAR, LLP

Dated: January 18, 2001

By: Adeel S. Akhtar

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